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To:	United States Patent and Trademark Office	From:	Jonathan A. Hack
Fax:	703.872.9306	Pages:	11 (including cover sheet)
Phone:		Date:	December 20, 2004
Re:	U.S. Application No.: 10/085,753	CC:	

U.S. Patent Application No. 10/085,753
Filed: February 28, 2002
Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON SEMICONDUCTOR WAFERS

CERTIFICATE OF TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following is being transmitted by facsimile to the U.S. Patent and Trademark Office (facsimile No. 703.872.9306) on December 20, 2004:

1. Petition For Three Month Extension of Time (1 page)
2. Amendment in response to the Office Action dated June 18, 2004 (9 pages)

By: Jonathan A. Hack
Reg. No. 47,623

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**PATENT
Attorney Docket No. TI-31620
Application No.: 10/085,753
Customer No.: 23494**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TSUGA et al.

Application No.: 10/085,753

Filed: February 28, 2002

For: **METHOD AND DEVICE FOR
REMOVING PARTICLES ON
SEMICONDUCTOR WAFERS**

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) **Group Art Unit: 1746**
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) **Examiner: Michael Komakov**
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Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 18, 2004, the period for reply having been extended for three months, December 18 being a Saturday, by a request for extension of time filed concurrently herewith, please amend the application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.